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CONFIRMATION NO. 8475

<b>SERIAL NUMBER</b> 10/811,152	<b>FILING OR 371(c) DATE</b> 03/29/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 123034-05004767
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## APPLICANTS

Ga Won Lee, Kyungki-Do, KOREA, REPUBLIC OF;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 10/028,972 12/28/2001 ABN *MA*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2001-36731 06/26/2001 *MA*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 06/10/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 6	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>M. Ahmad</i> Examiner's Signature	<i>MA</i> Initials			

## ADDRESS

43569

## TITLE

Method of forming inter-dielectric layer in semiconductor device

<b>FILING FEE RECEIVED</b> 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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